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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jeffrey Drue David Art Unit : 3723
Serial No. : 10/643,583 Examiner : Maurina T. Rachuba
Filed : August 18, 2003
Title : PLATEN AND HEAD ROTATION RATES FOR MONITORING CHEMICAL
 MECHANICAL POLISHING

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Applicant respectfully notes that not all of the limitations noted by the Examiner may be required for patentability, and that other reasons for patentability may exist.

Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 10/12/05

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